A BROADBAND COAXIAL NOISE SOURCE
PRELIMINARY INVESTIGATIONS

W. C. Daywitt
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Electromagnetics Division
Institute for Basic Standards
National Bureau of Standards
Boulder, Colorado 80302

October 1973

Interim Status Report
Contract No. CCG/Navy Blanket
Program 73-78

Prepared for
Department of Defense
Calibration Coordination Group
Attn: Melvin L. Fruechtenicht, Chairman
Army Metrology and Calibration Center
Redstone Arsenal
Huntsville, Alabama 35809
CCG 73-78
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ABSTRACT

This report describes investigations that were performed in fiscal year 1973, by the Noise and Interference Section of the Electromagnetics Division of the Institute for Basic Standards of the National Bureau of Standards preliminary to the design and construction of a coaxial thermal noise source in fiscal year 1974. The intent is to develop a coaxial thermal reference noise source that will operate at nominally 1000°C and will have a low reflection coefficient from 0.1 to 12 GHz.

Key words: Bead support; noise standard; resistive termination.
A BROADBAND COAXIAL NOISE SOURCE

Preliminary Investigations

INTRODUCTION

This report is a report to sponsor of a number of investigations that were performed during fiscal year 1973 in preparation for the design and construction of a coaxial thermal reference noise standard. The sponsor is the Calibration Coordination Group of the Department of Defense, and the task is designated by either number CCG 73-78 or NBS 2726449. The proposed noise standard is to have the following specifications:

1. Noise temperature output is to be nominally 1273 K.

2. Broadband characteristics require as low a reflection coefficient as possible from 0.1 to 12 GHz.

In order to design and build this high temperature, broadband noise standard four things are needed: 1) a method for calculating the noise temperature of the coaxial noise source; 2) an accurate method of measuring the dielectric constant of candidate inner conductor bead support materials usable at elevated temperatures; 3) a means for designing broadband bead supports for the inner conductor; and 4) a broadband termination design that will withstand usage at elevated temperatures.
In essence this year's work has been aimed at developing needed techniques and know how to accomplish the above. The following tasks emerged as the most critical for the success of these objectives:

1. to develop a technique for measuring dielectric constant at high temperatures;
2. to develop a predictable technique for designing low reflection bead supports for the center conductor of the noise source;
3. to investigate and select the most workable thin-film termination design;
4. experiment to find a means for retaining a thin-film on a ceramic substrate at or near 1000°C;
5. to try to develop a technique for adjusting the termination for a low reflection coefficient.

These tasks can be recognized as being mainly concerned with achieving a low reflection coefficient at high temperatures for the termination and transmission line. For comparison the original CCG work statement is included in its entirety as Appendix A.

Section one of this report describes a method for calculating the noise temperature output of a coaxial thermal noise source.

The first of the preceding five tasks has been completed and is discussed in section 2.
Task number two is 90% complete but was discontinued in this fiscal year for lack of funds. It appears that about three weeks of the next fiscal year effort will be needed for its completion. This task is discussed in section 3.

Task number three is tentatively complete with the choice of a conical termination design as discussed in section 4.

Task number four is approximately 50% complete and will be continued into the next fiscal year. It is discussed in section 4.

Task number five was not started in order to allow sufficient funds for task four and for writing this report. Some comments concerning this task will be found in section 4 however.

From the above it is apparent that task 2 was not completed, and that task 5 was not begun because of insufficient funds. Sixty thousand dollars was estimated to be needed to accomplish this year's work. Fifty-five thousand dollars were received, and it is estimated now that an additional six thousand dollars would have helped complete tasks two and five.
1. NOISE TEMPERATURE APPROXIMATION FOR A COAXIAL NOISE STANDARD

An accurate calculation of the noise temperature from a waveguide and a coaxial thermal noise standard differs in one important aspect. In a waveguide standard a single temperature distribution along the length of the waveguide is used. The coaxial standard in general has two such distributions, one for the inner and one for the outer conductor. It is this difference that prevents the direct use of previously developed equations for the calculation of the noise temperature.

Equation (1.1) is the formula used to calculate the noise temperature of a rectangular waveguide thermal noise source (Appendix B).

\[
\bar{T} = T_{\infty} \alpha_x + \int_0^L T_x \alpha'_x \, d\chi \quad (1.1)
\]

The quantity \(T_{\infty} \alpha_x\) is the contribution to \(\bar{T}\) from the termination, and the integral term is the contribution from the waveguide itself. Clearly the waveguide contribution depends on only one temperature distribution \(T_x\) along its length. This term can be rewritten as

\[
\int_0^L \frac{\alpha'_x}{\alpha_x} \, d\chi = 2 \int_0^L \left( \frac{1 + \frac{T_x}{\alpha_x}}{1 - \frac{T_x}{\alpha_x}} \right) T_x \alpha_x \, d\chi \quad (1.2)
\]

where \(\alpha_x\) is the real part of the propagation constant for the elemental length \(d\gamma\) of line at position \(\chi\) along the waveguide and \(\alpha_x\) is defined in Appendix B. It is significant that \(T_x\) and \(\alpha_x\) appear as a product.
In a coaxial noise source there are two temperatures associated with each point along the transmission line, one for the outer conductor and one for the inner conductor. However, $\Upsilon_y$ does not allow a separate identification of inner and outer conductor losses for the TEM wave. That is, $\Upsilon_x$ does not separate into the sum of two terms, one being solely identified with the outer conductor and one with the inner conductor. Without this separation the outer and inner conductor temperatures cannot be uniquely coupled with the outer and inner conductor losses respectively. Therefore the noise temperature of a coaxial thermal noise source cannot be calculated exactly. However, for low loss lines an approximate separation of $\Upsilon_x$ is possible and a first order approximation to the noise temperature is obtained. This approximation is developed in Appendices B and C, and it is shown there (Appendix B) that the resulting error in the noise temperature from using this approximation is negligible.

The result of this first order approximation for the noise temperature is given by equation B.9 of Appendix B.

$$T = T_m \alpha_o + 2 \int_0^2 \left( T_{\xi_i} \Upsilon_{\xi_i} + T_{\xi_o} \Upsilon_{\xi_o} \right) \left( \frac{1 + |T_{\xi_i}|^2}{1 - |T_{\xi_i}|^2} \right) \alpha_x \, d\alpha$$

where $T_{\xi_i}$ and $T_{\xi_o}$ are the temperature distributions for the inner and outer conductors respectively, and $\Upsilon_{\xi_i}$ and $\Upsilon_{\xi_o}$ are the first order separated real "propagation constants" for the inner and outer conductors respectively.
This result (eq 1.3) will be used to calculate the output noise temperature of the thermal noise source and will be the basis for developing an error analysis of the coaxial standard.

2. RESONANCE TECHNIQUE (TE01 CIRCULAR MODE) FOR MEASURING DIELECTRIC CONSTANT vs. TEMPERATURE

In the design, testing, and troubleshooting of the coaxial noise standard it will be necessary to identify and isolate reflections from a number of sources. One source of reflection is an impedance mismatch between the transmission line and the bead support(s) for the inner conductor. To minimize this mismatch in the initial design of the bead support(s) an accurate (i.e., ± 5% or better) measurement of the dielectric constant of the bead material is required at the working temperature. To this end the TE01 circular mode resonance technique \(^\text{(2)}\) was implemented, based on a brief survey of candidate methods for measurements up to 1000°C.

The technique (Appendix D) involves resonating the TE01 circular waveguide mode in a cylindrical dielectric sample that has been fitted into a uniform diameter hollow cylindrical tube. The resonant frequency satisfies the requirement that the TE01 mode propagates inside the sample but is cut off outside of the sample. Since the electric field in the sample vanishes at the inner surface of the tube, for this mode, a small air gap between the sample and pipe does not greatly affect the dielectric constant measurement. \(^\text{(2)}\) This lack of sensitivity to such gaps allows the sample to be heated with negligible error due to the gap produced by the heating.
The simplicity of the system can be explained with the aid of figure 1. RF energy is fed from the sweep generator into the coax-to-waveguide adaptor at the right end of the X-band waveguide structure. The rf energy proceeds through the isolated reaction cavity and directional coupler to a waveguide-to-3mm coaxial adaptor. The rf energy is coupled to the sample residing in the circular tube through a small magnetic probe at the end of the 3mm coaxial line. The reflected energy travels back through the 3mm line, through the adapter and up the vertical arm of the directional coupler to the tunable crystal detector. The detected signal is fed into the vertical display of the oscilloscope whose horizontal axis is being swept by the sweep output of the sweep generator. The oscilloscope display shows two resonances. The right one in figure 1 is the sample resonance and the left one is the resonance from the reaction cavity that is shown for comparison. The sample material whose resonance is being displayed is an isotropic pyrolytic boron nitride. A number of tubes and samples used during these preliminary investigations are shown under and to the left of the tube being used.

When a dielectric constant is to be measured at a high temperature a tube of high temperature metal containing the sample will be placed in an oven at the desired temperature. In this case a high temperature 3mm coaxial line will be used to excite the sample. This high temperature line is shown in the center of the figure leaning against the waveguide rail.
This technique requires that the product of the tube diameter \( D \) and the resonant frequency \( f \) must lie between the values shown in figure 2. Then if the approximate value of the relative dielectric constant \( \varepsilon_r \) (Appendix F) is known at the desired frequency an accurate value of \( \varepsilon_r \) at the same frequency can be obtained by adjusting the sample length and diameter with the aid of figure 2 and equations D.2 and D.3 of Appendix D.

To test the theory and the system a number of samples were measured and compared to measurements made using a slotted line technique that was adapted to measure \( \varepsilon_r \) at any given frequency. Figure 3 shows the results of these tests using two batches of boron nitride as the sample material. In the first column Cu or Al indicate resonance measurements in which a copper or aluminum tube was used for the circular waveguide. "Coax" indicates that the measurement was performed with the slotted line technique. The sample batch number indicates from which boron-nitride batch the sample was cut. The frequencies given in the sixth column are the measured resonance frequencies, or the frequencies at which the measurements were performed with the slotted-line technique.

By examining figure 3 the following conclusions and implications can be drawn:

1. Both the sets (coax and resonance measurements) have a high internal consistency. For example, the relative spreads in the value of \( \varepsilon_r \) measured by the resonance (1-6) and coax techniques (7, 8) about their average values are 0.24\% and 0.07\% respectively.
(2) Although both sets of measurements are repeatable to a fraction of a percent, they nevertheless differ by approximately 3% as evidenced by the average values of 4.632 and 4.490 measured via the resonance and coax techniques respectively.

(3) In the resonance measurements an air-gap does have a negligible effect on the measured values as evidenced from the small differences between the separate values and the average value of 4.632 for the resonance measurements.

(4) Since the measurements using the Cu and Al tubes give essentially the same results, the wall losses of the tubes have a negligible effect on the measured dielectric constant.

(5) A number of resonance measurements not appearing in this table were made with different sample loadings (different separation distances between the rf probe and the sample face) that indicate the results obtained to be free from excessive coupling.

The preceding results imply that the resonance technique is capable of measuring dielectric constants at elevated temperatures quite precisely although there is some question about the accuracy. Since there is a 3% difference between the coax and resonance measurements, a maximum error of 3% in the resonance technique will be assumed. This assumed error is not crucial to the concerns of this report, but does allow some order-of-magnitude
estimates to be made in section 3 under the "Formula Test Results."

Due to the non-crucial nature of the assumed error no extensive effort was used to track down the source of the discrepancy between the resonance and coax values for $\varepsilon_r$.

Once the final bead material or materials are chosen a high temperature tube or tubes of appropriate dimension will be purchased and the dielectric versus temperature measurements performed. At present not enough is known concerning the final design to allow this choice.

Another technique was partially investigated that may prove useful if it becomes necessary to measure dielectric constant versus frequency. This technique (Appendix F) utilizes an automatic network analyzer to measure the scattering coefficients of a two-port comprised of a coaxial reference air line filled with the dielectric material under question. From these measured scattering coefficients the analyzer calculates and prints out the dielectric constants for the frequencies of interest. This technique doesn't have a high degree of accuracy, but could nevertheless be used to confirm or eliminate the question of anomalous dielectric constant behavior should it arise.

3. BROADBAND BEAD DESIGN

The principal mode characteristic impedance $Z_0$ of a coaxial transmission line is given by equations 3.1 or 3.2
\[ Z_0 = \frac{1}{\varepsilon_0} \left( \frac{\mu_0}{\varepsilon_0} \right)^{1/2} \frac{1}{\varepsilon_r^{1/2}} \ln \frac{D_o}{D_i} \]  

\[ Z_0 = \left( \frac{\varepsilon_r}{\varepsilon_0} \right)^{1/2} \]  

where \( \mu_0 \) and \( \varepsilon_0 \) are the free space magnetic and electric permittivities respectively, \( \varepsilon_r \) is the relative dielectric constant of the material filling the line, \( D_o \) is the inner diameter of the outer conductor and \( D_i \) is the outer diameter of the inner conductor, and \( Z \) and \( C \) are the inductance and capacitance per unit length respectively of the line. In constructing a transmission line using bead supports for the inner conductor, \( Z_0 \) must be the same for each point along the length of line if the line is to be broadband, that is if the line is to have no reflections. For example, in the air filled region of a 50 ohm line the diameter ratio \( D_o/D_i \) in equation (3.1) must be chosen to make \( Z_0 \) equal to 50 ohms with \( \varepsilon_r \) equal to unity. However, within the bead supports whose relative dielectric constant might be 4 this ratio must be chosen to make \( Z_0 \) equal to 50 ohms with \( \varepsilon_r \) equal to 4. Therefore, at the interfaces between the bead supports and the air the diameters of the inner and outer conductors are abruptly changed to maintain the 50 ohm characteristic impedance. This abrupt change or step in the conductors produces an anomalous increase in the capacitance of the line at the step through the resulting fringing fields.
This step capacitance leads to a reflection since $C$ in equation (3.2) is increased by the step capacitance at the step and the resulting $Z_o$ is less than the desired 50 ohms. In order to decrease $C$ back to the correct value to make $Z_o$ 50 ohms, some of the capacitance at the step is removed by removing some of the material from the bead faces. This is usually accomplished by cutting a shallow toroidal groove in the bead faces concentric with the conductors. (6)

If the above is properly done, the line and bead supports will be reflectionless from dc up to the lowest frequency at which the higher modes begin to propagate within the bead, and it is therefore desirable to have a formula for predicting the lowest frequency for the onset of these modes.

3.1 Bead Support Design and Trimming

The design, construction, and subsequent trimming of bead supports to make them reflectionless is accomplished by the following procedure:

1. An accurate measurement (see Sec. 2) of the dielectric constant of the bead material is obtained.

2. Equation (3.1) is used to determine the correct diameter ratio for the conductors in the region of the bead support so that this region will have the correct characteristic impedance, $Z_o$, for the relative dielectric constant $\varepsilon_r$ of the material measured in step 1.

3. An upper limit to the length of the bead is obtained from the graph of the equation (J.6) in Appendix J (Fig. 4). This equation gives the frequencies at which the bead acts as a cavity at resonance for
the odd and even configurations of the TE11 circular waveguide mode. The odd and even configurations appear alternately as the frequency is increased, the first resonance to appear being that of the even configuration. The details of this equation are explained in Appendix J.

4. The diameter of the outer conductor is increased and/or the diameter of the inner conductor is decreased where the bead is to be placed in accordance with the value of \( D_o / D_t \) calculated in step 2. This increase and/or decrease in the diameters is not fully completed, however, allowing for some inaccuracy in the measurement of \( \varepsilon_r \). Later reflection measurements will indicate how much conductor trimming is left to be done. The length of the bead and the changed diameter portions of the line are determined in accordance with step 3, and a bead is cut to press fit into the enlarged line.

A graph of equation (J.6) for the first even and odd modes is shown in figure 4 for a 14 mm line and bead. The resonant frequencies for these modes are plotted horizontally for the bead lengths plotted vertically. For example, for a 2 cm bead with a dielectric constant equal to 4.56 with the dimensions given in the graph, the first resonance occurs at about 5.4 GHz. The next resonance to appear will be at about 6.8 GHz and is due to the first appearance of the odd mode. As the frequency is increased an infinite sequence of resonance frequencies...
are encountered. The cutoff frequency for these TE11 modes is 4.86 GHz for the dielectric constant in the figure and is a vertical asymptote for all the modes.

The actual bead length is then chosen to be less than that length where the first even mode appears for the highest frequency at which the bead and transmission line are to be used. For example, if the bead and line of figure 4 is to be used up to 9 GHz, the bead length should be no greater than 0.1 cm where the first even configuration appears. After the bead is compensated for the step capacitance it resonates at a frequency given by its original length minus the length removed. For example, if 0.2 cm were cut into each face of the 2 cm bead, its resonant length would be reduced to 1.6 cm and the corresponding first resonant frequency would be increased from 5.4 GHz to about 5.5 GHz.

5. The reflection coefficient magnitude (equation 3.3 below) of the bead and line is measured as a function of frequency on the automatic network analyzer, the data is plotted, and the constants $D$, and $D_2$ are determined. The resulting plot of such a measurement is shown in figure 5, where the dots represent measured data points. The abscissa is the measurement frequency in gigahertz and the ordinate is the reflection coefficient. The angles given under the major frequency divisions are the electrical angles ($2\pi f/f_o$).
corresponding to the given frequency, where \( f_0 \) corresponds to a full cycle or 360°. For example, 90° corresponds to 4.84 GHz and is that point where only the first term or \( D_1 \) is present from equation (3.3). The constants \( D_1 \) and \( D_2 \) of equation (3.3) for the reflection coefficient (see Appendix G for a derivation of this equation) are then chosen to make the equation fit the data points.

\[
|\Gamma| = \left| D_1 \sin \frac{2\pi f}{f_0} - \frac{D_2 f}{f_0} \cos \frac{2\pi f}{f_0} \right| \tag{3.3}
\]

where \( f_0 \) is that frequency for which the electrical length of the bead is one wavelength, and \( f \) is the measurement frequency. This equation is a first order equation in \( D_1 \) and \( D_2 f / f_0 \). \( D_1 \) is the reflection coefficient caused by the characteristic impedance of the bead being different from 50 \( \Omega \), and \( D_2 \) is the reflection coefficient caused by the step capacitance.

A nonvanishing \( D_1 \) indicates that the diameter ratio in equation (3.1) was not properly chosen for the given dielectric constant of the bead. If the outer conductor diameter \( \ell' \) in the bead region is too large by \( \delta \ell' \), and/or if the inner conductor diameter \( \alpha' \) in the bead region is too large by \( \delta \alpha' \), and/or if \( \varepsilon_r \) is too large by \( \delta \varepsilon_r \), then the resulting reflection \( D_1 \) is related to \( \delta \ell', \delta \alpha', \) and \( \delta \varepsilon_r \) by (see Appendix G for details)

\[
D_1 = \frac{\delta}{\varepsilon_r} \left( \frac{\delta \ell'}{\ell'} - \frac{\delta \alpha'}{\alpha'} \right) + \frac{1}{2} \frac{\delta \varepsilon_r}{\varepsilon_r} \tag{3.4}
\]
In using equation (3.4) to determine what correction to the conductor diameters or $\varepsilon_r$ is needed to make $D_1$ vanish, either $\varepsilon \varepsilon_r'$, $\varepsilon \varepsilon_r''$, or $\varepsilon \varepsilon_r$, or any two of these can be taken as zero and the correction made entirely on only one of them.

Before any compensation of the bead for the reflection caused by the step capacitance is made $D_2$ will be nonvanishing. $D_2$ is related to the step capacitance $C$ (see Appendix I) through the relation

$$D_2 = (D_2)_0 (1 - d/d_0) \quad (3.5)$$

where

$$(D_2)_0 = 2\pi f_0 \ell_0 \overline{C} \quad (3.6)$$

$(D_2)_0$ is the value of $D_2$ before any compensating cuts ($d = 0$) are made into the bead faces, $d$ is the cutting depth, and $d_0$ is that depth of cut which perfectly nullifies ($D_2 = 0$) the reflection from the step capacitance.

A rough estimate of $d_0$ (see Appendix I) is given by

$$d_0 = \frac{\overline{C} \varepsilon_0 \ell (D_2)_0}{2\pi f_0 (\gamma_{0z}^2 - 1)} \quad (3.7)$$

where

$$\gamma_{0z}^2 = \varepsilon_r / \varepsilon_{re} \quad (3.8)$$
$\epsilon_{re}$ (see Appendix I) is the effective relative dielectric constant in the portions of the bead where the compensating toroidal cuts have been made, and $l$ is the bead length. Since this first measurement is made before any bead compensating is done ($d = 0$), the value of $D_k$ determined is the same as $(D_k)_0$.

Equation (3.7) is now used to determine what approximate depth of compensation of the bead will cancel the reflection from the step capacitance.

6. After $d_0$ is determined from step 5, a toroidal cut is made into both faces of the bead to a depth that is some fraction of $d_0$ (e.g. 1/2 or 1/3), and another set of reflection measurements is made and plotted. Again $D_i$ and $D_2$ are determined from the graph. If $D_i$ agrees with the previous $D_i$ measured in step 5, it is safe to change the conductor diameters accordingly in the region of the bead. If not, then enough care was not taken in fitting the bead in the line and the process in the previous steps should be repeated until agreement is obtained. Great care must be exercised in the machining and fitting of the line and bead if the value measured for $D_i$ is to be meaningful. The second measured value of $D_2$ should show some agreement with equation (3.5).

7. Steps 5 and 6 are repeated until the bead-line reflection coefficient is reduced to or below the desired value.
**Formula Test Results**

This first set of results is meant to show that the preceding formula and ideas have sufficient validity to be gainfully used in the design and construction of broadband bead supports.

The first group of results pertain to figures 4, 5, 6, and 7. Figure 6 is an exploded view of the 14 mm bead-line test apparatus, consisting of an air line whose diameters have been changed in the bead region. The bead is made of boron nitride and is fitted onto the center conductor. A compensation groove can be seen in the visible face of the bead. Figure 4 has been discussed and is used to predict the bead resonant frequencies for the 14 mm bead and line. Before any compensation was performed the predicted resonant frequency corresponding to the bead length of 0.725 cm was approximately 6.4 GHz. This prediction compares well with the measured resonant frequency of 6.7 GHz indicated in figure 5. After a 0.152 cm compensation cut was made into both faces the effective length of the bead was reduced from 0.725 cm to 0.421 cm. The predicted resonant frequency corresponding to this length is 7.2 GHz as obtained from figure 4. This value compares well with the measured value of 7.6 GHz as shown in figure 7. The broad spike at 5.8 GHz in figure 7 is believed to be generated in the network analyzer and is not a resonance. This coupled with further experiments indicates that equation (J.6) of Appendix J is quite adequate for predicting the onset frequency for bead resonances, at least for 14 mm and 7 mm lines with bead supports of moderate dielectric constant.
The calculation of the step capacitance of the 14 mm bead before compensation using equation (H.1) of Appendix H gave 0.21 picofarads for \( C \). The measured value obtained from \( (D_2)_0 \) through equation (3.6) was 0.22 picofarads, in good agreement with the calculated value. The second order value of 1.35 for \( D_2 \) was used in equation (3.6) although the first order value, that obtained from equation (3.3), would also have given good agreement. The second order value was obtained using a second order equation for \( \|w\| \) analogous to the first order equation given by (3.3). This was done to better understand the data points and equation (3.3), and to get a better expression for determining the value of the step capacitance for \( d=d_0 \), and consequently the relationship (I.9) in Appendix I. According to equation (3.3) the data points in figure 5 should pass through zero at 4.84 GHz. The fact that they do not is due to the first order nature of equation (3.3).

From figure 5 and the value of 1.35 for \( D_2 \) the depth of compensation cut needed to nullify the reflection from the step capacitance is 0.153 cm as calculated from equation (3.7). After a cut of 0.152 cm was made into each face the resulting \( D_2 \) is +0.0071 as seen in figure 7. The corresponding \( D_\| \) calculated from equation (3.5) is +0.009 in good agreement with the measured value.

The value of \( D_1 \) obtained from figure 5 is approximately zero, showing that the diameter ratio in equation (3.1) is apparently close to correct.
for the value of $\varepsilon_r$ measured for the bead. However, the value calculated from equation (3.4) is -0.046, taking $\delta \omega$ and $\delta \varepsilon_r$ to be zero. The value obtained from figure 7 for $D_1$ is -0.045 in close agreement with the calculated value of -0.046. $D_1$ should be the same for both figures 5 and 7. The discrepancy implied by $D_1 \approx 0$ from figure 5 can only mean therefore that $-\delta \varepsilon_r / 2 \varepsilon_r$ in equation (3.4) must have been approximately equal to +0.046 to offset the first term in equation (3.4), giving approximately zero for $D_1$. The only way this could have happened is for $\delta \varepsilon_r / \varepsilon_r$ to be approximately -9.2%, a number three times larger than the maximum measurement error of 3% for $\varepsilon_r$ assumed in section 2. This leads to the conclusion that the outer diameter of the bead used for figure 5 was undersized and that the bead used for figure 7 was a good fit. This was indeed the case, and it points up the extreme care needed in fitting the bead into the line.

Figure 8 shows an exploded view of the 7 mm bead holder that was constructed to further test the design formula. The bead is made from boron nitride, and with the line is dimensioned such that at least two bead resonances will appear in the 0 to 12 GHz frequency range. This picture was taken after the bead had been partially compensated and the groove can be seen around the center conductor of the line. The reflection coefficient measured on the automatic network analyzer for this line and bead before the bead was compensated is plotted as a function of frequency in figure 9. Again the isolated
points represent the measured data and the solid curve represents the best fit for equation (3.3). At around 4.5 GHz the curve and data points begin to diverge possibly owing to the first order nature of equation (3.3). The sudden jump in the data points at 9.5 GHz is apparently due to the measurement apparatus since this jump is not explainable by the bead reflections or resonances. The value for $D_2$ implies a step capacitance of 0.26 picofarads, while the value calculated from equation (H.1) is 0.29 picofarads. Using equation (3.4), the value of $D_1$ indicates that the diameter of the outer conductor is too small by $18\% \left(0.1 \times 5 \times \frac{\epsilon_r^{1/2}}{\phi}\right)$, or that the diameter of the inner conductor is too large by $18\%$, or that $\epsilon_r$ is too large by $20\%$. If the value for $D_1$ is correct it indicates that the conductors should be changed accordingly to reduce $D_1$ to zero, or in this case since $\delta \epsilon_r$ is positive, $\epsilon_r$ could be reduced to some effective value (Appendix I) 20% lower than its present value to accomplish the same end. The ability to tune the bead by lowering its dielectric constant through removing some of the bead material the whole length of the bead should prove quite useful later on in the standard's development. Two resonant frequencies in the 0 - 12 GHz range are predicted for the bead by equation (J.6) in Appendix J, the lower resonant being that of the first even mode and the second being that of the first odd mode. The values predicted for these resonant frequencies are 5.5 GHz and 8.3 GHz, both of which are $14\%$ lower than the measured values of 6.4 GHz and 9.6 GHz.
**Gap Experiment Results**

Even if a bead and line are press fit together, when they are both heated a small gap may appear between one of the outer conductors and the bead. This gap will both change the bead characteristic impedance and its step capacitance, causing the reflection coefficient to increase. The work of Cruz (7) with effective dielectric constants implies that this gap problem can be circumvented by inserting $\varepsilon_{re}$ in place of $\varepsilon_r$ in the design and trimming formula, where $\varepsilon_{re}$ is less than $\varepsilon_r$ and accounts for the gap. The expression for $\varepsilon_{re}$ in this case can be obtained from equation (1.2) of Appendix I by using equation (I.1) and letting $\theta''$ equal $\theta'$, and $\alpha''$ equal the reduced bead outer diameter $\theta' - 2g$ where $g$ is the gap width. Then

$$
\varepsilon_{re} = \frac{\varepsilon_r}{1 + (\varepsilon_r - 1) \ln \frac{\theta'}{\ln(\theta' / \alpha')}}
$$

Equation (3.9)

Although in reality the gap will not be concentric with the conductors, it is expected that the eccentricity is a second or higher order effect and that this treatment of the gap problem will still be useful. The experiment to be described now supports this conclusion. It consists of constructing a bead whose outer diameter is 5 mils (0.013 cm) smaller than the outer line diameter of the 14 mm line. In other words the bead and line are the same as in figure 6 with the bead reduced by 5 mils in its outer diameter. The reflection coefficient
of the bead and line is then measured before and after compensation and
the measurement results compared with those predicted by equations (3.3),
(3.6), and (3.7), and equation (H.1) of Appendix H.

Figure 10 shows the measurement results before compensation.
The best fit for $|\Gamma|$ is given by $-0.033$ and $0.859$ for $D$, and $D_z$ respectively.
Equation (3.6) and the measured value of $D_z$ lead to a value of 0.14 pico-
farads for the step capacitance $C$. The value obtained for $C$ from equation
(H.1) is 0.19 picofarads which compares favorably with the measured value. The depth $d_o$ of cut to provide full compensation calculated
from equation (3.7) and equation (1.2) is 0.097 cm. The predicted TE11
resonant frequency using equation (J.6) of Appendix J is 6.4 GHz compared
to a measured value of 6.9 GHz. The range of values obtained for $D_1$
is $-0.08$ to $-0.04$ using equation (3.4) with $\varepsilon_{c e}$ of equation (3.9) replacing
$\varepsilon_r$ to account for the gap. The measured value for $D_1$, before and after
compensation is $-0.033$ in good agreement with the calculated range of
values for $D_1$.

Figure 11 shows the measured reflection coefficient of the bead with
a 5 mil gap after a compensation cut to a 0.048 cm depth had been made.
In this case the bead length for the TE11 resonance calculation is reduced
by 0.096 cm giving a resonant frequency of 6.6 GHz as compared to the
measured value of 7.1 GHz. $D_1$ is the same, $-0.033$, as in figure 10 as
it should be since no changes to the bead or line diameters have been made.
The new measured value for $D_z$ is 0.431. The value calculated for $D_z$
using equation (3.5) with $\epsilon_0 = 0.097$, $\epsilon = 0.048$, and $(\bar{D}_2)_0 = 0.859$ is 0.434 which closely agrees with the measured value.

These results show that it is possible to trim a bead and line to achieve a low reflection coefficient even though a gap is present. Although the gap chosen for these measurements was between the outer diameters of the bead and line, these results imply that the same trimming procedure applies to a gap between the bead and line inner diameters.

As a bead and line are heated a gap may also appear between the bead faces and the inner and outer conductor steps next to these faces. This gap will modify the step capacitances which, hopefully, can still be accounted for in the same manner indicated in equation (3.4). However, for lack of time no experiments were conducted to test this statement.

4. BROADBAND TERMINATION DESIGN

Resistive Element Selection

In selecting an appropriate resistive terminating configuration, several different types were considered. Among these were various thin film configurations such as the cylindrical center element with a tractorial outer conductor, the conical center element with a cylindrical outer conductor and several strip line element types (5, 8, 9). Also, the solid lossy element types were considered.
The conical center element of figure 12 was selected because of the simplicity of design, ease of machining and greater predictability. Also, another group in Division 272 has had considerable past experience with this type of terminating element.

**Materials Selection**

The 12 GHz upper frequency limit and especially the 1000°C operating temperature place very severe requirements on the materials to be used in the terminating element. The conical substrate and the metallic resistive film must maintain their mechanical and electrical properties up to these limits as well as remain chemically and mechanically compatible with one another.

A literature search for high temperature materials narrowed the choices of suitable substrate materials to a very few. Certain types of boron nitride and beryllium oxide appeared to have very good mechanical and electrical characteristics over the ranges of temperature and frequency of interest. Sapphire, alumina, quartz and silica also seemed to be possible candidates. Samples of pyrolytic isotropic boron nitride, hot pressed boron nitride and beryllium oxide were obtained for initial testing.

Some materials considered as possibilities for the resistive thin film were platinum, rhodium, titanium, tantalum and tungsten. For the first attempt, an alloy of 90% platinum and 10% rhodium was selected. This material was selected because of high melting point, the excellent chemical properties at high temperatures and the vast amount of published
material dealing with the mechanical and electrical characteristics of this alloy. Also, this material has been used in previous high temperature applications with good success. (1)

High Temperature Materials Testing

Several samples each of pyrolytic isotropic boron nitride, hot pressed boron nitride and beryllium oxide were sent out to a local firm for deposition of thin films of the 90% platinum 10% rhodium alloy. The film on each sample was deposited to produce approximately 30 ohms per square.

One sample of each type was subjected to 1000°C for several hours. All three samples failed. Severe surface glazing was experienced with both types of boron nitride. This glazing is believed to result from water absorption by the material prior to film deposition. It has since been observed at temperatures as low as 700°C. The beryllium oxide sample appeared to withstand the temperature but resistance measurements of the film revealed that it had become non-conductive.

Boron nitride as a substrate material has been, at least, temporarily set aside in favor of beryllium oxide. Samples of BeO with the Pt-Rh alloy film have been run in an argon atmosphere and in a vacuum furnace in an effort to determine the cause of the film failure at 1000°C. In all tests the film failed in less than one hour when run at 1000°C. Also, the failure takes place somewhere between 900°C and 1000°C. Samples have been run at 900°C for several days without any sign of change or failure of either the resistive film or the BeO substrate.
Gold was deposited on two samples of BeO and tested at 900°C and 1000°C. These films failed also by becoming non-conductive. However, since several hours were required at 1000°C and two days at 900°C, it is suspected that these failures resulted from sublimination.

**Resistive Element Design**

Design equations for the tapered conical load are described in Appendix L. A computer program utilizing these equations has been written to calculate the various dimensional requirements (figure 12) for conical substrates of different dielectric constants and for different coaxial line sizes. The program was used to design a 7 mm conical termination to be used at room temperature to gain insight into the characteristics of this type of termination. This termination and its associated housing are shown in figures 13 and 14, respectively.
The authors gratefully acknowledge help from the following persons:

Dr. Howard E. Bussey, W. J. Foote, P. E. Werner, and other personnel from Section .55 who helped with the use of the Automatic Network Analyzer.
5. FIGURES

1. TE01 Circular Mode Dielectric Measurement System
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6. 14 mm Bead and Line
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8. 7 mm Bead and Line
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13. Resistive Cone
14. Cone Holder
15. Equivalent Circuit for Derivation of Equation G.11
16. Profile View and Equivalent Circuit for Derivation of Equation I.11
17. Profile View for Derivation of Equation J.6
18. Graph of \((1 + k)\sqrt{11}\)
Figure 1. TE01 Circular Mode Dielectric Measurement System.
Figure 2. D-F Graph for TE01 Measurement.
<table>
<thead>
<tr>
<th>Tube</th>
<th>Sample Diameter (cm)</th>
<th>Sample Batch Number</th>
<th>Sample Diameter (cm)</th>
<th>Sample Length (cm)</th>
<th>Measured Frequency (GHz)</th>
<th>Relative Dielectric Constant</th>
<th>Loss Tangent</th>
</tr>
</thead>
<tbody>
<tr>
<td>Cu</td>
<td>2.007</td>
<td>1</td>
<td>2.007</td>
<td>0.828</td>
<td>9.827</td>
<td>4.635</td>
<td>0.0009</td>
</tr>
<tr>
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<td>1</td>
<td>2.007</td>
<td>0.808</td>
<td>9.917</td>
<td>4.632</td>
<td>0.0009</td>
</tr>
<tr>
<td>Cu</td>
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<td>1</td>
<td>2.007</td>
<td>0.726</td>
<td>10.110</td>
<td>4.630</td>
<td></td>
</tr>
<tr>
<td>Cu</td>
<td>2.007</td>
<td>1</td>
<td>1.999</td>
<td>0.726</td>
<td>10.115</td>
<td>4.625</td>
<td></td>
</tr>
<tr>
<td>Cu</td>
<td>2.007</td>
<td>2</td>
<td>2.007</td>
<td>0.772</td>
<td>10.016</td>
<td>4.634</td>
<td></td>
</tr>
<tr>
<td>Coax</td>
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<td>2</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Coax</td>
<td>14 mm</td>
<td>2</td>
<td>5 cm</td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Al</td>
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<td>1</td>
<td>*</td>
<td>0.726</td>
<td>10.589</td>
<td>4.636</td>
<td>0.0013</td>
</tr>
</tbody>
</table>

* Diameter reduced by hand to fit tube. Bad job - visible air gap between sample and tube.

Figure 3. Table of TE01 Measurements for Various Materials.
Figure 4. Bead Resonant Frequencies for TE11 Circular Mode in 14 mm Bead.
<table>
<thead>
<tr>
<th></th>
<th>AIR LINE</th>
<th>BEAD RESONATOR</th>
<th>BEAD</th>
</tr>
</thead>
<tbody>
<tr>
<td>INNER DIA. (cm)</td>
<td>0.620</td>
<td>0.281</td>
<td>0.281</td>
</tr>
<tr>
<td>OUTER DIA. (cm)</td>
<td>1.429</td>
<td>1.589</td>
<td>1.589</td>
</tr>
<tr>
<td>LENGTH (cm)</td>
<td>0.725</td>
<td>0.725</td>
<td></td>
</tr>
</tbody>
</table>

$\varepsilon_r = 4.56$

$f_0 = 19.35$GHz $\sim 360^\circ$

Figure 5. Measurement Data for 14 mm Bead-Line Before Compensation.
Figure 6. 14 mm Bead and Line.
\[ |\Gamma| = \left| D_1 \sin \frac{2\pi f}{f_0} - \frac{D_2 f}{f_0} \cos \frac{2\pi f}{f_0} \right| \]

**BEST FIT:** \( D_1 \approx -0.045, \ D_2 \approx +0.0071 \)

Figure 7. Measurement Data for 14 mm Bead-Line After Compensation.
Figure 9. Measurement Data for 7 mm Bead-Line Before Compensation.
| INNER DIA(cm) | .620 | .302 | 1.563 |
| OUTER DIA(cm) | 1.429 | 1.589 |
| LENGTH (cm) | .725 |

$\varepsilon_r = 4.695$

$\varepsilon_{e_0} = 4.529$

$f_0 = 19.42$

CURVE:

$$|I| = |D_1 \sin \frac{2\pi f}{f_0} - \frac{D_2 f}{f_0} \cos \frac{2\pi f}{f_0}|$$

BEST FIT: $D_1 = -0.033$, $D_2 = +0.859$

Figure 10. Measurement Data for 14 mm Bead-Line-Gap Before Compensation.
BEAD AIR RESONATOR LINE CAVEITY BEAD

| INNER DIA(cm) | 0.620 | 0.302 | 0.302 |
| OUTER DIA(cm) | 1.429 | 1.589 | 1.563 |

$\varepsilon_r = 4.695$, $\varepsilon_{ ero} = 4.529$, $f_0 = 19.42$GHz

\[
|\Gamma| = \left| D_1 \sin \left( \frac{2\pi f}{f_0} \right) - D_2 \cos \left( \frac{2\pi f}{f_0} \right) \right|
\]

**BEST FIT:** $D_1 = -0.033$, $D_2 = +0.431$

Figure 11. Measurement Data for 14 mm Bead-Line-Gap After Compensation.
Figure 12. Resistive Cone and Cone Holder for 7 mm Termination.
Figure 15. Equivalent Circuit for Derivation of Equation G.11.
Figure 16. Profile View and Equivalent Circuit for Derivation of Equation I.11.
Figure 17. Profile View for Derivation of Equation J.6.
Figure 18. Graph of \((1 + k)X'11\).
APPENDIX A

CCG Work Statement

A. Project Title: Reference Noise Standard Development

B. Objective:

1. General: To develop an excess noise reference standard to provide a basis for support of waveguide and coaxial noise sources in use within the Department of Defense.

2. FY 1973 Work Statement:

   a. Investigate and establish the direction for the design and development of a calculable reference standard noise source meeting the following technical requirements:

      (1) Output Level: Optimize for use with the AIL type 82 system.

      (2) Frequency Range: At least 100 MHz to 12 GHz.

      (3) Stability: Suitable for use as a primary reference standard for eight years.

      (4) Output Connector Type: Selected to minimize comparison errors when calibrating standards with waveguide, 14 mm, 7 mm, 3.5 mm and type N precision connectors.

      (5) Operation Requirements: Suitable for operation by standards laboratory personnel.
(6) Physical Requirements: Suitable for operation in a standards laboratory and capable of being transported between laboratories.

b. Prepare a detailed report on the noise source requirements and investigation results.

C. Background: The requirement exists within DOD to measure the operating noise figure of RADAR, missile, ECM and communications receivers using automatic noise figure meters and excess noise sources. The reliability of these measurements depend, among other things, upon the accuracy in the excess noise ratio value (dB) assigned to the noise source by DOD calibration laboratories. Over the frequency range of 0.5 to 7 GHz, these values are not tested due to the lack of a primary reference within DOD and at NBS. The major thrust of this effort is to provide the basis to fill this gap in our measurement system.

D. Approach:

1. Investigate and establish the direction for the design and development of a calculable reference standard noise source. Prepare a report documenting the noise source requirements and the investigation results.

2. Develop and evaluate design approaches for a reference standard noise source. Prepare a report documenting the design approaches, test results and the proposed design for a prototype standard.
3. Develop and evaluate a prototype reference standard noise source meeting stated technical specifications. Prepare a report including a description of the development and evaluation of the prototype, design drawings and test and operating instructions.

E. Milestones:

1. Evaluate loss, VSWR and repeatability on required coaxial connectors to determine the effects on final accuracies and decide on transmission line dimensions. 3 Aug 72

2. Estimate feasible temperature distribution for transmission lines necessary to achieve reasonable accuracy. 30 Sep 72

3. Complete accurate determination of dielectric constants for proposed bead materials. 31 Oct 72

4. Establish feasible design of a broadband, low VSWR transmission line using beads to support the inner conductor. 31 Dec 72

5. Determine feasibility of using heat pipes to achieve required temperature distribution of transmission line. 31 Jan 73

6. Complete investigation of tractrix design at room temperature for a broadband low VSWR termination. 28 Feb 73
7. Complete evaluation of feasibility of the manner of bead supporting the inner-conductor for 1000°C application.

8. Complete the determination of the design for the termination required to achieve a broadband low VSWR termination that will withstand temperature cycling to 1000°C. Complete final report for this phase of the project.

30 Apr 73

30 Jun 73
APPENDIX B

Output Noise Temperature for a Coaxial Thermal Noise Source

First Order Calculation

An approximate expression for the noise temperature of a coaxial thermal noise source is developed in this appendix. This equation takes into account the different temperature and resistivity distributions along the inner and outer conductors respectively.

The development starts from equation (N.2) of NBS Technical Note 615\(^{(1)}\) which gives the output noise temperature, \(T\), of a thermal noise source in kelvins.

\[
T = T_{\infty} \alpha_o + \int_0^l \frac{\alpha_x}{T_X} \alpha'_x \, dx
\]

(B.1)

where \(T_{\infty}\) is the physical temperature (in kelvins) of the resistive element terminating the line; \(\alpha_o\) is the available power ratio (less than unity) of the line from the termination at \(x=0\) to the output connector at \(x=l\); \(T_X\) is the physical temperature (in kelvins) at \(x\) of the inner and outer conductor of the line; and \(\alpha'_x\) is the gradient at \(x\) of the available power ratio of the line. The first term in equation (B.1) is the noise from the generating resistor attenuated by the line arriving at the output connector from the termination, while the second term is the noise generated by the line arriving at the output connector. The line is assumed to be slightly lossy, but otherwise ideal. The connector is assumed to be lossless and reflectionless.
The second term can be rewritten as

$$\int_0^L \left( \frac{I_x \alpha_x' \Delta x}{L_x} \right) \alpha_x' \, \Delta x$$

(B.2)

where the parenthetical factor is the noise power generated in the elemental piece of line $\Delta x$ at $x$. This factor applies to the case where the inner and outer conductor have the same temperature and resistivity distributions as a function of $x$ along their lengths. The purpose of this appendix is to develop an approximation for this factor that applies to a coaxial line where both distributions may be different.

The factor $\alpha_x'/\alpha_x$ will not in general separate into a sum of two terms, one representing the inner conductor loss and one representing the outer conductor loss. Therefore, it is not possible in general to determine how much of the noise is generated in either conductor separately, a determination made important by the differing temperature distributions of the inner and outer conductors. However, to first order in the propagation constant (Appendix C) this factor is separable, allowing a separation of the noise into a contribution from the inner and from the outer conductors.

From Technical Note 615

$$\alpha_x = \left( \frac{1 - \beta_x^2\beta_x^2}{\frac{1}{\beta_x^2} + \beta_x^2} \right) e^{-2\int_0^L \alpha_x' \, \Delta x}$$

(B.3)
where

\[ |\Gamma_x| = |\Gamma_q| \ e^{-2\int_0^x \mathcal{U}_x \, dx} \]

and where \( \mathcal{U}_q \) is the real part of the propagation constant for the principle or TEM mode. \( \Gamma_q \) is the reflection coefficient of the terminating element.

From (B.3) it can be shown that

\[ \frac{\mathcal{U}_x'}{\mathcal{U}_x} = 2 \mathcal{U}_x \left( \frac{1 + |\Gamma_x|^2}{1 - |\Gamma_x|^2} \right) \]  

(B.4)

Since \( \Gamma_x \) is the reflection coefficient looking toward the termination from the elemental segment of line dx at x and does not involve dx itself, only \( \mathcal{U}_x \) characterizes the loss of dx and consequently the noise generated by it. \( \mathcal{U}_x \) does not separate into a simple linear combination representing the inner and outer conductor losses. However, to first order \( \mathcal{U}_x \) becomes (Appendix C)

\[ \mathcal{U}_x = \mathcal{U}_{x_i} + \mathcal{U}_{r_o} \]  

(B.5)
in which case

$$\frac{\alpha_x}{\alpha_y} = 2 \left( U_{xi} + U_{xo} \right) \left( \frac{1 + |\alpha_x|^2}{1 - |\alpha_x|^2} \right)$$

(B.6)

Since the inner and outer conductor losses are now separate and identifiable their separate noise contributions can also be identified. Correspondingly, if the inner and outer conductors have temperature distributions $T_{xi}$ and $T_{xo}$ respectively, the noise from $dx$ is given by

$$2 \left( T_{xi} U_{xi} + T_{xo} U_{xo} \right) \left( \frac{1 + |\alpha_x|^2}{1 - |\alpha_x|^2} \right) \, dx$$

(B.7)

This noise is attenuated by $\alpha_x$ before it reaches the end of the line at the output connector. Thus the total noise output from the line is

$$2 \int_0^L \left( T_{xi} U_{xi} + T_{xo} U_{xo} \right) \left( \frac{1 + |\alpha_x|^2}{1 - |\alpha_x|^2} \right) \, \alpha_x \, dx$$

(B.8)

which is the sum of the attenuated noise contributions from each of the elemental line segments.

When the attenuated noise power $\overline{T_m \alpha_o}$ from the termination is added to (B.8), the noise output $T$ from the source is

$$T = T_m \alpha_o + 2 \int_0^L \left( T_{xi} U_{xi} + T_{xo} U_{xo} \right) \left( \frac{1 + |\alpha_x|^2}{1 - |\alpha_x|^2} \right) \, \alpha_x \, dx$$

(B.9)
Error in the First Order Calculation

By assuming a single average temperature distribution for the inner and outer conductors which is flat from the termination to some point where the distribution goes through a transition to room temperature and is again flat out to the output connector, an order of magnitude estimate of the relative error $\Delta T$ in the noise temperature $T$ is obtained and is given by

$$\frac{\Delta T}{T} \approx \frac{\Delta T_1}{T_m} \cdot \frac{\Delta T_2}{\Delta T_1} \quad (B.10)$$

The first factor $\Delta T_1 / T_m$ is the relative correction to the termination temperature, and the second factor $\Delta T_2 / \Delta T_1$ is the relative error in this correction. Using the above distribution an estimate for the factors results in the following two equations:

$$\frac{\Delta T_1}{T_m} \approx \frac{1}{2^{1/2}} \frac{R \ell}{Z_0} \left( \frac{T_2 - T_m}{T_m} \right) \quad (B.11)$$

and

$$\frac{\Delta T_2}{\Delta T_1} \approx \frac{R_e}{\omega L_0} \quad (B.12)$$

$\ell$ is the length of line from the start of the temperature transition to the output of the source, $R$ is the average resistance per unit length for the length of line $\ell$, $T_2$ is room temperature, $Z_0$ is the characteristic line impedance, and $L_0$ is the line inductance per unit length.
For the standard envisioned in this report the relative error calculated from equation (B.10) is of the order of $10^{-7}$. 
APPENDIX C

Propagation Constant of a Coaxial Line

The real part $\mu$ of the propagation constant for the TEM mode in a coaxial line is given by

$$ \mu = 2^{-1/2} \left\{ \left[ \omega^2 L^2 + \sigma_{\text{int}} \frac{L^2}{D_{\text{int}}} \right]^{1/2} + \sigma_{\text{out}} - \omega^2 L C \right\}^{1/2} \quad (C.1) $$

where

$$ R = \left( \frac{f}{\pi} \right)^{1/2} \left[ \frac{\sigma_{\text{int}}}{D_{\text{int}}} + \frac{\sigma_{\text{out}}}{D_{\text{out}}} \right] = \sigma_{\text{int}} + \sigma_{\text{out}} $$

$$ L = L_0 + \frac{R}{\omega}, \quad L_0 = \frac{\mu L_{\text{D}_{\text{out}}}}{2 \pi} $$

and

$$ C = \frac{2 \pi \varepsilon_0 \varepsilon_r}{\mu \ln D_{\text{out}} / D_{\text{in}}} $$

$D_{\text{in}}$ = outer diameter of inner conductor,

$D_{\text{out}}$ = inner diameter of outer conductor,

$f$ = frequency in hertz

$\omega$ = $2\pi f$

$\sigma_{\text{int}}$ = resistivity of inner conductor in ohm-meters,

$\sigma_{\text{out}}$ = resistivity of outer conductor in ohm-meters,
\[ \mu_\alpha = \text{magnetic permeability of the dielectric (air) between conductors in henry/meter}, \]
\[ \mu_{c1} = \text{magnetic permeability of inner conductor in henry/meter}, \]
\[ \mu_{c2} = \text{magnetic permeability of outer conductor in henry/meter}, \]
\[ \varepsilon_\infty = \text{dielectric constant of free space in farad/meter}, \]
\[ \varepsilon_r = \text{relative dielectric constant of dielectric (air)}, \]
\[ R = \text{resistance in ohms/meter}, \]
\[ L = \text{inductance in henry/s/meter}, \]
\[ C = \text{capacitance in farads/meter}, \]
\[ G = \text{conductance in mhos/meter (zero for air dielectric)}. \]

To second order in \( R/\omega L_0 \) and \( G/\omega C \)

\[ U = \frac{\omega(L_C \alpha)^{1/2}}{2} \left( \frac{R}{\omega L_0} + \frac{G}{\omega C} + \frac{RG}{2\omega^2L_0C} - \frac{R^2}{2\omega^2L_0^2} \right) \quad (C.2) \]

For a line containing a perfect dielectric \(( G = 0) \), to second order in \( R/\omega L_0 \)

\[ U = \frac{\omega(L\alpha)^{1/2}}{2} \frac{R}{\omega L_0} \left( 1 - \frac{R}{L\omega L_0} \right) \quad (C.3) \]

which reduces to first order in \( R/\omega L_0 \) when

\[ R \ll \omega L_0. \quad (C.4) \]

When (C.4) holds, \( U \) can be written as

\[ U = U_{c1} + U_\infty \quad (C.5) \]
where

\[ \psi_i = \omega \left( \frac{L_0 C^{\frac{1}{2}}}{2} \frac{P_i}{\omega L_0} \right) \]  \hspace{1cm} (C.6)

and

\[ \psi_0 = \omega \left( \frac{L_0 C^{\frac{1}{2}}}{2} \frac{P_0}{\omega L_0} \right). \]  \hspace{1cm} (C.7)
APPENDIX D

Design Formula for the TE01 Circular Mode Resonance Measurement

An intuitive picture of the relative dielectric constant measurement using the TE01 circular resonance in a waveguide-below-cutoff cylinder containing a sample of the material under consideration can be drawn as follows. Consider a hollow air-filled cylinder which is below cutoff for a particular waveguide mode, but which is above cutoff inside a dielectric material sample located in the cylinder. Then for a particular length of such a sample there exists a particular frequency for which the cylinder and sample act as a resonant cavity at its resonance frequency. This frequency is uniquely related to the sample length, the diameter of the cylinder, and the dielectric constant of the sample. Therefore, if the length and diameter are known, the measurement of the resonant frequency will yield the dielectric constant of the sample. It will clearly work only when the mode propagation constant is real inside the sample and imaginary outside. From Appendix E it can be seen that this requirement implies that

\[ \lambda_c^2 < \lambda^2 < \lambda_c^2 \varepsilon_r \]

where \( \lambda \) is the free space wavelength, \( \lambda_c \) is the cutoff wavelength in the sample free part of the cylinder, and \( \varepsilon_r \) is the relative dielectric constant of the sample material. In terms of the frequencies corresponding to these wavelengths,
defines the range of frequencies over which a resonance can be expected to work (figure 2).

The circular TE01 mode is particularly useful in high temperature measurements since its electric field vanishes at the cylinder walls. Therefore, the resulting measurement of \( \varepsilon_r \) is much less susceptible to error from air gaps between the sample and the cylinder, allowing the cylinder and sample to be heated without introducing large errors. A useful expression for \( \varepsilon_r \) is (Appendix E with \( A = 1 \))

\[
\varepsilon_r = \frac{L^2}{\lambda_{gd}^2} + \frac{L^2}{\lambda_c^2} \tag{D.2}
\]

where \( \lambda_{gd} \) is the guide wavelength in the dielectric.

For the TE01 mode in a sample of length \( L \) to resonate \( \lambda_{gd} \) is given by

\[
\lambda_{gd} = \frac{\pi L}{y} \tag{D.3}
\]

where \( y \) is a solution of the equation

\[ y \tan y = C \]

and

\[ C = \frac{\pi L}{\lambda_c} \left( \frac{L^2}{\lambda_c^2} - 1 \right)^{1/2} \]
The cutoff wavelength for a particular diameter $D$ is given by

$$\lambda_c = 0.320D$$

(D.4)

for this mode.
APPENDIX E

Propagation Constant in a Lossy Dielectric

This appendix contains an expression for the propagation constant that is used in the two preceding appendices and is given here for convenient reference.

The propagation constant for a particular mode in an ideal waveguide of cylindrical symmetry filled with a lossy dielectric is given by

\[ \gamma = \alpha + \beta \]  

(E.1)

where

\[ \alpha = \frac{\beta \tan \delta}{2 \varepsilon_1} \]

\[ \beta = \beta_0 \varepsilon_r^{1/2} \varepsilon_i \]

\[ \beta_0 = \frac{2\pi}{\lambda} \]

\[ \varepsilon_i = 2^{1/2} \left[ 1 - \frac{\lambda^2}{\lambda_0^2 \varepsilon_r} \right]^{1/2} \left[ 1 + \left( 1 + \frac{\tan^2 \delta}{(1 - \lambda^2 / \lambda_0^2 \varepsilon_r)^2} \right)^{1/2} \right]^{1/2} \]

\[ \lambda_{\varepsilon_0} = \frac{2\pi}{\beta} \]

In these expressions, \( \tan \delta \) is the dielectric loss tangent, \( \varepsilon_r \) is the relative dielectric constant (Appendix F), \( \lambda \) is the free space wavelength, and \( \lambda_{\varepsilon_0} \) is the
guide wavelength in the dielectric, and \( \lambda_c \) is the cutoff wavelength for the
air filled guide. \( \lambda_c \) is infinite for the TEM mode of propagation.

These expressions can be manipulated to give the following expression
for \( \varepsilon_r \):

\[
\varepsilon_r = \frac{\lambda_c^2}{\lambda_c^2} + \frac{A^4 \rho^2}{\lambda_c^2 \delta}
\]

(E.2)

where

\[
A \equiv \frac{1}{\varepsilon_i} \left( 1 - \frac{\lambda_c^2}{\lambda_c^2 \varepsilon_r} \right)^{1/2}.
\]

For most cases \( \varepsilon_r \) is given by equation (E.2) with \( A \) equal to one. For large
loss tangents however a better value for \( \varepsilon_r \) is given by equation (E.2) by
iteration, starting with \( A \) equal to one, obtaining the first approximation to
\( \varepsilon_r \), and proceeding to iterate using the resulting value of \( A \).
APPENDIX F

Dielectric Constant Measurement Using the Automatic Network Analyzer

The complex relative dielectric constant of a dielectric material completely filling a length of ideal waveguide is given by (12, 13)

$$\varepsilon = \varepsilon' - j\varepsilon'' = \varepsilon_r (1 - \tan \delta)$$

and is obtained from the ANA data as:

$$\varepsilon = \frac{(1 + S_{11} S_{22} - S_{12} S_{21} - 1)}{(1 + S_{11} S_{22} - S_{12} S_{21} + 1)}$$

$$= \frac{(1 - S_{11})^2 - S_{12}^2}{(1 + S_{11})^2 - S_{12}^2}$$  (F.1)

where the $S$'s represent the components of the $2 \times 2$ scattering matrix representing the length of dielectric filled waveguide section being measured. $\varepsilon_r$ is the relative dielectric constant and is equal to $\varepsilon'$. $\tan \delta$ is the loss tangent and is the ratio of $\varepsilon''$ to $\varepsilon'$. The last expression obtains where the waveguide and material form a reciprocal junction.

These expressions are used in the following program written for the automatic network analyzer (13):
ANA Program

5 DIM E[88], G[88]
6 PRINT
7 PRINT
10 REM DIELECTRIC ANALYSIS
15 LET Q1=Q2=Q3=Q4=Q9=0
20 DIM S[32], D[88,4], M[88], F[88], A[88], B[88]
25 LET C9=2.99659E-04
26 PRINT "AVERAGE DATA? ";
27 CALL (41, L1)
29 IF L1=0 THEN 26
30 CALL (3, S[17, 7, 1])
40 LET F=S[27]
60 LET M1=3*(N-S[14])+1
70 CALL (3, D[N1, 1], M, N)
80 NEXT N
90 LET M1=1+(S[12]-S[11])/S[13]
100 FOR N=1 TO M1
130 NEXT N
150 REM CALC E PARAMETERS
155 CALL (14, 1, 0, C1)
156 IF L1=1 THEN 3000
160 FOR N=1 TO M1
170 LET K=M[N]
175 IF S[31]=1 THEN 210
180 LET S1=D[K, 1]
185 LET S2=D[K, 2]
190 LET S3=D[K, 3]
195 LET S4=D[K, 4]
200 GOTO 230
210 LET S1=D[K, 1]
215 LET S2=D[K, 2]
220 LET S3=D[K, 3]
225 LET S4=D[K, 4]
230 CALL (12, S2, S3, C3)
235 CALL (12, S1, S4, C4)
240 CALL (10, S1, S4, C5)
245 CALL (12, C1, C4, C4)
250 CALL (11, C4, C3, C3)
255 CALL (13, C3, C5, C2)
260 CALL (11, C2, C1, C4)
265 CALL (19, C2, C1, C5)
270 CALL (13, C4, C5, C6)
280 CALL (15, C6, E[N]=1, G[N])
290 LET G[N]=-G[N]
300 IF G[N]>0 THEN 315
312  LET G(N)=0
315  IF L1=1 THEN 400
320  NEXT N
325  PRINT
330  PRINT " FUNCTION ";
335  INPUT J
340  IF J=1 THEN 400
345  IF J=2 THEN 540
350  IF J=3 THEN 1033
355  IF J=4 THEN 9000
360  GOTO 360
365  REM
370  PRINT "TITLE?";
375  CALL (41,Q)
380  PRINT
385  PRINT "FREQ";TAB(13)"E"(MEAS)";TAB(27)"E"(MEAS)";
390  PRINT TAB(41)"N";TAB(58)"K"
395  PRINT
400  IF L1=1 THEN 445
405  FOR N=1 TO M1
410  IF ETN>1 THEN 743
415 gosub 645
420  PRINT F(N);TAB(14);E(N);TAB(25);G(N);TAB(43);D2;TAB(55);D1
425  GOTO 508
430  PRINT "BAD DATA"
435  IF L1=1 THEN 610
440  NEXT N
445  PRINT
450  PRINT "TITLE ?";
455  CALL (41,Q)
460  PRINT
465  PRINT "RESISTIVITY WAVELENGTH"
470  PRINT "FREQ";TAB(14)"(DB/IN)";TAB(23)"(DB-1AY)";
475  PRINT TAB(41)"(OHM-C";"";TAB(53)"(IN)"
480  PRINT
485  IF L1=1 THEN 641
490  FOR N=1 TO M1
495 gosub 645
500  GOTO 720
505  LET K4=SQRT(E(N)+2+G(N)+2)
510  LET D1=SQR(.5*(K4-E(N)))
515  LET D2=SQR(.5*(K4+E(N)))
520  LET D3=3.68A*D1*E(N)*2.54
525  LET D4=11992.7/(E(N)*D1)
530  LET D5=((1+D2)^2+D1+2)/((1-D2)^2+D1+2)
535  LET D5=D5/(D5-1)
540  LET D6=4.34Q*LOG(D5)
545  IF G(N)>2 THEN 710
550  PRINT
555  LET D7=9.68A*D1*E(N)*2.54
560  LET D8=11992.7/(E(N)*D1)
565  LET D9=((1+D2)^2+D1+2)/((1-D2)^2+D1+2)
570  LET D9=D9/(D9-1)
575  LET D10=4.34Q*LOG(D9)
580  IF G(N)>2 THEN 710
585  PRINT
590  LET D11=9.68A*D1*E(N)*2.54
595  LET D12=11992.7/(E(N)*D1)
600  LET D13=((1+D2)^2+D1+2)/((1-D2)^2+D1+2)
605  LET D13=D13/(D13-1)
610  LET D14=4.34Q*LOG(D13)
615  IF G(N)>2 THEN 710
620  PRINT
625  LET D15=9.68A*D1*E(N)*2.54
630  LET D16=11992.7/(E(N)*D1)
635  LET D17=((1+D2)^2+D1+2)/((1-D2)^2+D1+2)
640  LET D17=D17/(D17-1)
645  LET D18=4.34Q*LOG(D17)
650  IF G(N)>2 THEN 710
655  PRINT
660  LET D19=9.68A*D1*E(N)*2.54
665  LET D20=11992.7/(E(N)*D1)
670  LET D21=((1+D2)^2+D1+2)/((1-D2)^2+D1+2)
675  LET D21=D21/(D21-1)
680  LET D22=4.34Q*LOG(D21)
685  IF G(N)>2 THEN 710
690  PRINT
695  LET D23=9.68A*D1*E(N)*2.54
700  LET D24=11992.7/(E(N)*D1)
705  LET D25=((1+D2)^2+D1+2)/((1-D2)^2+D1+2)
710  LET D25=D25/(D25-1)
715  LET D26=4.34Q*LOG(D25)
720  IF G(N)>2 THEN 710
LET D7 = 1.03700E+20
GOTO 715
LET D7 = 1.83700E+36/(G(N)*F(N))
RETURN
PRINT F(N);TAB(13);D3;TAB(25);D6;TAB(40);D7;TAB(51);F2
GOTO 745
PRINT "BAD DATA"
IF LI = 1 THEN 9000
NEXT N
GOTO 330
REM PLOT ROUTINE
PRINT "SET PAPER SCALE ?"
CALL (41,0)
IF Q = 1 THEN 1130
IF Q = -1 THEN 1200
GOTO 1310
CALL (49,15,J1)
WAIT (530)
IF J1 < 0 THEN 1195
CALL (49,9,J2)
IF J2 < 0 THEN 1170
GOTO 1185
CALL (43,255,255,1)
GOTO 1133
CALL (43,9,3,1)
GOTO 1130
CALL (43,3,0,1)
REM
CALL (43,255,9,1)
LET J8 = 2
PRINT "PLOT TYPE, SCALE ";
INPUT J9,J8
IF J9 = 1 THEN 360
IF J9 < 1 THEN 1265
IF J9 > 1 THEN 1265
FOR I = 1 TO 81
IF J9 = 1 THEN 1400
IF J9 = 2 THEN 1420
IF J9 = 7 THEN 1440
GOSUB 645
IF J9 = 3 THEN 1500
IF J9 = 4 THEN 1520
IF J9 = 5 THEN 1540
IF J9 = 6 THEN 1560
IF J9 = 8 THEN 1580
IF J9 = 9 THEN 1600
LEF Y = E(N)
GOTO 1700
LET Y = 30N1
GOTO 1700
LET Y = E(N)/500
GOTO 1700
69
1500 LET Y=D2
1510 GOTO 1730
1520 LET Y=D1
1530 GOTO 1700
1540 LET Y=D3
1550 GOTO 1700
1560 LET Y=D6
1570 GOTO 1700
1580 LET Y=D7
1590 GOTO 1700
1600 LET Y=D4
1610 GOTO 1700
1700 GOSUB 2000
1710 NEXT N
1720 GOTO 1260
2000 REM PLOT DATA POINTS
2005 IF E(N)<1 THEN 2350
2010 LET X=55*(.434*LOG(F(N))-2)
2020 LET Y=127.5*(.434*LOG(Y)+2-J3)
2030 IF Y>0 THEN 2050
2040 LET Y=0
2050 IF Y <= 255 THEN 2070
2060 LET Y=255
2070 CALL (43,X,Y,1)
2080 RETURN
3000 CALL (14,1,0,C8)
3010 LET J=1
3015 GOSUB 3200
3023 CALL (13,Z,C8,S1)
3025 LET J=2
3030 GOSUB 3200
3035 CALL (13,Z,C8,S2)
3042 IF S(31)=-1 THEN 3100
3045 LET S3=S2
3050 LET S4=S1
3055 GOTO 3150
3100 LET J=3
3105 GOSUB 3200
3110 CALL (13,Z,C8,S3)
3115 LET J=4
3120 GOSUB 3200
3125 CALL (13,Z,C8,S4)
3150 LET N=1
3160 LET F(1)=(F(1)+F(N))/2
3170 GOTO 232
3200 CALL (14,1,0,Z)
3210 FOR N=1 TO \"!
3220 LET Y=0\"
3230 CALL (13,D(K,J),Z,Z)
3240 NEXT \"!
3250 RETURN
9932 CALL (2,F)
9999 END
APPENDIX G

Curve Fitting Equation for Bead and Line Trimming

MacKenzie and Sanderson (5) give a formula for the imaginary part of the impedance at the center of a dielectric bead in a coaxial line as a function of frequency. They use this formula to determine the amount of under and/or overcutting of the line, and beadface compensation necessary to achieve a low VSWR for the bead support. Since they do not give a derivation of this formula, this appendix is devoted to deriving a formula for the reflection coefficient of the bead analogous to their formula for the imaginary part of the impedance.

Figure 15 is a schematic representation for the TEM mode representation for a bead in a coaxial line. The region between and including the step discontinuity capacitances $C$ (Appendix H) is the region in which the bead support resides. The capacitances arise from the step introduced by overcutting of the outer conductor and undercutting the inner conductor to make $Z$, the characteristic impedance of the line in the bead region, the same as $Z_0$, the characteristic impedance of the normal air filled portion of the line. The presence of the additional capacitances $C$ introduces a lumped circuit shunt reactance at the bead faces thus producing a reflection of the TEM wave. In order to offset this additional capacitance and do away with the reflection, some of the dielectric material is removed from the bead faces, i.e., a groove is cut in each face.
The impedance $Z_2$ is the parallel combination of the capacitance $C$ and the characteristic impedance $Z_0$. This impedance will be more fully discussed later in Appendix I.

The impedance $Z_3$ is $Z_2$ transformed through the bead region. For the lossless bead

$$Z_3 = Z_1 \left( \frac{Z_2 + j\beta \tan \theta}{Z_2 + j\frac{Z_0}{\lambda} \tan \theta} \right) \quad (G.1)$$

where $\beta$ is the imaginary part of the propagation constant in the bead, or

$$\beta = \frac{2\pi C_s \varepsilon_r}{\lambda}$$

$\varepsilon_r$ is the real part of the relative dielectric constant, and $\lambda$ is the free space wavelength. Finally $Z$ is the impedance at the other face of the bead consisting of $1/\omega C$ and $Z_3$ in parallel, and is supposed to equal $Z_0$ for reflectionless bead design.

$$Z = \frac{Z \cdot Z_3}{Z_3 - \frac{1}{Z} X} \quad (G.2)$$

where

$$X = \frac{1}{\omega C}$$

$\Gamma$ is the reflection coefficient looking to the right into the bead and is given by

$$\Gamma = \frac{Z - Z_0}{Z + Z_0} \quad (G.3)$$
When $-jX$ is expressed in terms of $Z_o$ and $Z_2$, this equation can be written in terms of $Z_o$, $Z$, $Z_2$, and $\tan \beta l$. Since $Z$, and $Z_2$ will be close to $Z_o$, it is convenient to write

$$Z_1 = Z_o + \delta Z_1$$

and

$$Z_2 = Z_o + \delta Z_2$$

where $\delta Z_1$ and $\delta Z_2$ are small and vanish as the bead and line are trimmed. When these are substituted into (G.1), and (G.3) is reduced to first order in $\delta Z_1$ and $\delta Z_2$, the following expression for the magnitude of $\Gamma$ results:

$$|\Gamma| = |\delta Z_1 \sin \beta l + \delta Z_2 C \cos \beta l|$$

where $\delta Z_1$ and $\delta Z_2$ are the impedances $\delta Z_1$ and $\delta Z_2$ divided by $Z_o$, or the corresponding magnitude of the reflections caused by $Z_1$ being different from $Z_o$, and $C$ being nonzero, respectively.

Using the expression for $Z_2$ given in Appendix I leads to

$$\delta Z_2 = -\frac{D_2 f}{Z_o}$$

where

$$D_2 = (D_2)_0 (1 - d/d_0)$$
$$d_0 = \frac{\delta_0}{(\delta_0^2 - 1)}$$
$$\delta_0^2 = \left(\epsilon_r/\epsilon_e\right)^{1/2}.$$
$d$ is the depth of the compensation cut into the bead faces, $d_0$ is the depth of cut for full compensation, $(\mathcal{D}_d)_0$ is the measured reflection from the bead faces at $\tilde{f}_0$ where the bead is one wavelength in length, $Z_0$ is the desired characteristic impedance (50 ohms), $\varepsilon_r$ is the relative dielectric constant of the bead material, $\varepsilon_{re}$ is the effective relative dielectric constant of the bead in the compensated region for which $Z_{02}$ is the normalized characteristic impedance, and $l$ is the total bead length.

$Z_l$ is given by

$$Z_l = \frac{\ln \frac{d}{d'}}{\varepsilon_{re} \ln \frac{d}{d'}} \tag{G.7}$$

where $a$ and $b$ are the inner and outer conductor diameter respectively in the air-filled regions, and $a'$ and $b'$ are the conductor diameters in the bead region that have been chosen to make $Z_l$ approximately one. If $a'$ and $b'$ have been chosen correctly for the given dielectric constant, then $Z_l$ will be unity. However, if $a'$ is too large by $\delta a'$ and $b'$ is too large by $\delta b'$, and $\varepsilon_r$ too large by $\delta \varepsilon_r$, that is using

$$a' + \delta a'$$

$$b' + \delta b'$$

$$\varepsilon_r + \delta \varepsilon_r \tag{G.8}$$

then using (G.7) and (G.8) and keeping only first-order terms in $\delta a'/a'$, $\delta b'/b'$ and $\delta \varepsilon_r/\varepsilon_r$ gives (for the 50 ohm line)

$$\delta Z_l = \frac{\delta \varepsilon_r}{5 \varepsilon_r} \left( \frac{\delta b'}{b'} - \frac{\delta a'}{a'} \right) - \frac{1}{2} \frac{\delta \varepsilon_r}{\varepsilon_r} \tag{G.9}$$
The electrical phase shift $\phi l$ can be interpreted in the following way:

$$\phi l = \frac{2\pi c}{\lambda} l_e = \frac{2\pi f}{c} l_e$$  \hspace{1cm} (G.10)

where

$$l_e f_0 = \nu$$

$l_e$ is the electrical length across the bead, $\nu$ is the speed of light, and $f_0$ is the frequency for which $l_e$ is one wavelength.

Equation (G.5) can now be rewritten as

$$|\Pi| = \left| D_1 \sin \frac{2\pi f}{f_0} - D_2 f \cos \frac{2\pi f}{f_0} \right|$$  \hspace{1cm} (G.11)

where

$$D_1 = \frac{6}{5 \varepsilon_r^{1/2}} \left( \frac{\delta b'}{\delta a'} - \frac{\delta a'}{\delta a'} \right) - \frac{1}{2} \frac{\delta \varepsilon_r}{\varepsilon_r}$$

and

$$D_2 = (D_2)_0 \left( 1 - d/d_0 \right)$$

Equation (G.11) is used in the bead and line trimming procedure for obtaining a low reflection coefficient.
APPENDIX H

Step Capacitance

Combining the equations given in Moreno\(^{(11)}\), the following expression for the step capacitance in picofarads at the uncut face of the bead support results:

\[
C = \pi \varepsilon_r \left[ \ell_r \varepsilon_i \left( \frac{b-a}{b'-a'} \right) + \varepsilon \varepsilon_i \left( \frac{b-a}{b'-a'} \right) \right] \quad (H.1)
\]

where the first capacitance per unit length \(\varepsilon_i\) is given by figure 6-21 in Moreno and the second by figure 6-22. \(\varepsilon_r\), \(\varepsilon\), \(\ell\), \(a\), and \(b\) are defined in Appendix G. After some of the face material has been removed this capacitance changes to \(C'\), where

\[
C > C' > \varepsilon_{re} C / \varepsilon_r \quad (H.2)
\]

and where \(\varepsilon_{re}\) is the effective dielectric constant associated with the compensated part of the bead (Appendix I).

The value for \(C\) given by (H.1) should be multiplied by a frequency factor\(^{(11)}\) when \(\lambda\), the free space wavelength, becomes an appreciable percentage of \(b-a\); and should also be multiplied by a proximity factor\(^{(11)}\) accounting for interactions between the fringing fields from the step discontinuities when the bead length approaches \(b-a\).
APPENDIX I

Effective Dielectric Constant and Face Compensation

In order to nullify the step capacitance and its resultant reflection, a toroidal groove is cut into each end face of the bead support. The depth to which this groove is cut is determined by the amount of step capacitance to be nullified, the dielectric constant, and the inner and outer diameter of the toroid.

An exact formula for the compensation depth can only be obtained by a detailed consideration of the interaction between the evanescent modes, the step, and the compensated bead. An investigation of this magnitude is both beyond the scope and needs of this report. Therefore, the following intuitive derivation is presented that gives an order-of-magnitude estimate of the depth. It has proven quite useful and adequate for the purpose of trimming beads.

Figure 16 shows a profile section of one end of the bead support and its equivalent circuit. The compensating toroidal region of length \( \ell \) has an effective dielectric constant \( \varepsilon_{\text{eff}} \). \( \mathcal{L}_0 \) is the capacitance per unit length in the uncompensated bead region. Through this compensating region of characteristic impedance \( \mathcal{Z}_0 (\neq \mathcal{Z}_0) \), the TEM wave travels with a propagation constant \( \beta \). The magnitude of the step capacitance \( C' \) lies between \( C \) and \( \varepsilon_{\text{eff}} C / \varepsilon_r \) depending on the dimensions of the toroidal compensating section where \( C \) is the step capacitance when \( \ell = 0 \) or before any compensation.
is effected. The diameters of the various regions are shown in the profile, and are such that

\[
\ln \frac{b}{a} = \frac{\ln \frac{b'}{a'}}{\varepsilon_r}
\]

which gives a characteristic impedance of \( Z_0 \).

Using the equations given by Cruz, the following relationships can be derived for \( \varepsilon_{re} \), \( \lambda_0 \), and \( \lambda \).

\[
\varepsilon_{re} = \frac{\varepsilon_r}{1 + \left( \frac{\varepsilon_r - 1}{\varepsilon_{r,2}} \right) \frac{\ln \frac{b''}{a''}}{\ln \frac{b}{a'}}}
\]

\[
\kappa_0 = \frac{2\pi \varepsilon_r \varepsilon_0}{\ln \frac{b}{a'}}
\]

\[
\lambda = \frac{\varepsilon_{re} \rho_0}{\varepsilon_0}
\]

where \( \varepsilon_0 \) is the free space dielectric constant.

The impedance \( Z_L \) is given by

\[
Z_L = Z_0 z \left( \frac{Z + j Z_0 \tan \beta \lambda}{Z_0 + j \frac{Z}{Z_0} \tan \beta \lambda} \right)
\]

where \( z \) is the parallel combination impedance of \( C' \) and \( Z_0 \).
That is,

\[ Z = \frac{1}{Z_0 - \frac{1}{Z_0}} \]

\[ \approx Z_0 \left( 1 - \frac{1}{Z_0 / X} \right) \]

where

\[ X = \frac{1}{\omega C'} \]

and where \( \omega \) is the radian frequency. The approximation in equation (I.6) is quite adequate for the present needs.

When equation (I.5) is reduced to first order in \( Z_0 / X \) the following expressions result:

\[ \delta g_2 = \frac{\left( \frac{3g_2 - 1}{g_2^2} \right) \tan \beta}{1 + \frac{1}{g_2^2} \tan \beta} - \frac{1}{X} \]

where

\[ g_2 = \frac{Z_2 / Z_0}{1 + \beta^2} \]

\[ g_{20} = \frac{Z_{20} / Z_0}{\left( \epsilon_r / \epsilon_{r0} \right)^{1/2}} \]

\[ X = \frac{X}{Z_0} \]

\[ \beta = \frac{2 \pi \epsilon_r^{1/2}}{\lambda} \]

where \( \lambda \) is the free space wavelength. Then \( \delta g_2 \) can be reduced to

\[ \delta g_2 = 2 \pi i \nabla \left[ \frac{\epsilon_{r0}^{1/2}}{Z_0} \left( \frac{g_{20}^2 - 1}{g_{20}^2} \right) - C' \right] \]

where \( \nabla \) is the free space speed of light and \( f \) is the frequency.
The approximation \( \tan \beta d \approx \beta d \) has been used in arriving at equation (1.8) and is in keeping with the approximate nature of the derivation. For the experimental work it is convenient to define a measured parameter \( D_2 \) which represents the reflection coefficient caused by the uncompensated or partially compensated step capacitance.

\[
D_2 \equiv - \frac{6}{\epsilon} \epsilon_{r_2} \quad (1.9)
\]

where \( D_2 \) is frequency independent.

It has already been stated that the step capacitance \( \epsilon' \) is a function of the dielectric configuration to the left of the step capacitance in figure 16. From what has been stated in Appendix H it is clear that \( \epsilon' \) can vary from \( \epsilon \) given by equation (H.1) for \( d = 0 \), to \( \epsilon_{r_0} \epsilon / \epsilon_r \) when \( d = \infty \). There is some depth \( d_0 \) where the compensating toroid just nullifies \( \epsilon \) causing the reflection and \( D_2 \) to vanish. It has been found experimentally that \( \epsilon' \) is given approximately by \( \epsilon (\epsilon_{r_0} \epsilon) \epsilon_{r_0}/ \epsilon_r \) when \( d = d_0 \). That is, the value \( \epsilon_{r_0} \) of the dielectric constant for \( \epsilon' \) when the compensation depth is correct (no reflections) is given approximately by the geometric mean of \( \epsilon_r \) and \( \epsilon_{r_0} \). Clearly, \( \epsilon_{r_0} \) varies in some nonlinear fashion as \( d \) is varied. However, for the estimate here it is sufficient to assume that \( \epsilon_{r_0} \) varies linearly from \( \epsilon_r \) when \( d = 0 \) to \((\epsilon_{r_0} \epsilon_{r_0})^{\frac{1}{2}} \) when \( d = d_0 \). That is

\[
\epsilon_{r_0} = \epsilon_r - \left( \frac{\epsilon_r - (\epsilon_{r_0} \epsilon_r)^{\frac{1}{2}}}{d_0} \right) d \quad (1.10)
\]
When equations (1.8), (1.9), and (1.10) are combined the following approximation for the measured parameter \( D_2 \) results:

\[
D_2 = (D_2)_0 \left( 1 - \frac{d}{d_0} \right)
\]  

(1.11)

\[
d_0 = \frac{2 \log (D_2)_n \lambda}{2 \pi \log \left( \frac{D_2}{\lambda^2} - 1 \right)}
\]  

(1.12)

where \( (D_2)_0 \) is the value of \( D_2 \) when \( d = 0 \), and \( \lambda \) is the total bead length.
APPENDIX J

Higher Mode Bead Resonances

In an unpublished paper (14) Bussey and Beatty show a way to calculate higher mode bead resonances in a coaxial line that is not over or undercut. They have indicated that, in the case of over or undercutting, their simple approach must be modified in three essential ways: 1) the $\theta_a$ for the appropriate regions, the uncut and cut region, must be used; 2) some account for the step capacitance due to the cutting must be made; and 3) since the two regions have different dimensions, the characteristic impedances for the higher modes rather than their wave impedances must be used in the impedance transformation formula.

Following is a derivation for the resonant frequencies of the TE modes in a bead where the inner and outer conductors may be under or overcut respectively. The derivation ignores modifications 2 and 3 above, but follows the Bussey and Beatty derivation for the uncut line almost step for step. The only justification offered for this procedure is that it has proven useful in predicting the TE11 resonant frequencies observed in the experiments.

Figure 17 shows a coaxial line in the region of a dielectric bead support. $\mathcal{Z}_o$ and $\mathcal{Z}_d$ are the characteristic impedances (taken to be the wave impedances) for the air and dielectric regions of the line respectively. $\gamma_o$ and $\gamma_d$ are the propagation constants of the two regions, ($\mathcal{E}^{-\gamma L}$ understood) and $\lambda_o$ and $\lambda_d$ are their cutoff wavelengths. The impedance $\mathcal{Z}$ is given in terms of $\mathcal{Z}_i$ by
\[ Z = Z_d \left( \frac{Z_s + Z_d \tanh \frac{\lambda d}{2}}{Z_s + Z_d \tanh \frac{\lambda d}{2}} \right) \]  \hspace{1cm} (J.1)

where

\[ Z_d = \frac{\omega \mu}{q_d} \]

and (14)

\[ Z_s = \infty \quad \text{for the even cavity modes} \]
\[ Z_s = 0 \quad \text{for the odd cavity modes}, \]

\( \omega \) is the radian frequency; \( \mu \) is the magnetic permeability of the dielectric bead which is taken to be that of air.

Further,

\[ Z_0 = \frac{\omega \mu}{q_0} \]  \hspace{1cm} (J.2)

The propagation constants are given by

\[ \beta_d = \frac{j2\pi (\varepsilon_s - \lambda^2/\alpha_d)}{\lambda} = \beta_d \]  \hspace{1cm} (J.3)

and

\[ \beta_0 = \frac{2\pi (\lambda^2/\alpha_0 - 1)^{1/2}}{\lambda} \]

The cutoff wavelengths for the TE\textsubscript{m1} modes are (11)

\[ \lambda_c = \frac{\pi \varepsilon_s (1+l_1/k)}{(1+k_1)\lambda_{m1}} \]  \hspace{1cm} (J.4)
where \( b \) is the inside diameter of the outer conductor, \( k \) is ratio of the outer conductor inner diameter to the inner conductor outer diameter, and the denominator is obtained either from tables, or graphically (see Appendix K).

The condition for resonance is taken to be

\[
\frac{\mathcal{Z}}{\mathcal{Z}_o} = 1
\]  

(14)

where the star signifies complex conjugate. This condition leads to the following conditions for resonance

\[
\tan \beta_{1/2} = \begin{cases} 
\left(1 - \frac{\lambda^2 / \lambda_c^2}{\varepsilon_r - \lambda^2 / \lambda_c^2}\right)^{1/2} \\
\left(\frac{\lambda^2 / \lambda_c^2 - 1}{\varepsilon_r - \lambda^2 / \lambda_c^2}\right)^{1/2}
\end{cases}
\]  

(J.6)

for the odd modes

for the even modes

After a compensation cut into the bead faces has been made, \( l \) is taken to be the length of the uncut portion of the bead between the bead faces.
APPENDIX K

TEll Cutoff Wavelengths

The cutoff wavelengths for the higher TEml modes in a coaxial line are given by equation (J.4) of Appendix J. The denominator of that expression for the TEll mode can be obtained from figure 18 which is a graph of the denominator as a function of k. $\kappa_{\parallel}$ is a root of

$$J_1'(\kappa) N_1'(k\kappa) - J_1'(k\kappa) N_1'(\kappa) = 0 \quad (K.1)$$

for a given value of k. J and N are Bessel functions of the first and second kinds respectively. A table of values for x as a function of k extensive enough for the present investigations was not found. Therefore a simple graphical technique (15) which only requires evaluating the ratio $\mathcal{J}_1(\kappa) / \mathcal{N}_1(\kappa)$ was employed to find the needed roots. This technique considerably reduces the effort in finding x for equation (K.1), and provides sufficient accuracy for the needs explained in Appendix I.
APPENDIX L

Termination Design Equations

The resistance of a truncated cone of semi-angle \( \Theta \) (figure 12) and \( \rho \) surface resistivity is given in the paper by Woods\(^{(8)}\) as

\[
R = \frac{\rho \ln b/a}{2\pi \sin \Theta} \quad (L.1)
\]

which reduces to the familiar equation

\[
Z = \frac{Z_\infty \ln b/a}{2\pi} \quad (L.2)
\]

where \( Z \) is the wave impedance of the medium.

Since the main field penetrates the film and sets up auxiliary fields within the substrate, there are interactions which take place. The resulting second order effects are handled by the following (figure 12)

\[
\frac{d\rho}{d'} = 1 + \frac{\epsilon_\infty \sin^2 \Theta}{4} \quad (L.3)
\]

and

\[
\frac{\rho}{d'} = \frac{\rho}{d'} \quad (L.4)
\]
5. REFERENCES


(13) Holley, A., Private Communication, Hughes Aircraft Company.


(15) Truell, R., "Concerning the Roots of $J_n(x)N_0(kx) - J_n(kx)N_0(x) = 0$," *J. of Appl. Phys.*, Vol. 14, p. 350, July 1943.
This report describes investigations that were performed in fiscal year 1973, by the Noise and Interference Section of the Electromagnetics Division of the Institute for Basic Standards of the National Bureau of Standards preliminary to the design and construction of a coaxial thermal noise source in fiscal year 1974. The intent is to develop a coaxial thermal reference noise source that will operate at nominally 1000°C and will have a low reflection coefficient from 0.1 to 12 GHz.